Search Notes		

Application/Control No.	Applicant(s)/Patent under Reexamination
10/074,193	SHI ET AL.
Examiner	Art Unit
Kevin Y. Kim	2634

	SEARCHED				
Class	Subclass	Date	Examiner		
375	229 (296 (pd atts	6/9/05	Ku		
4)	pdatt				
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
375	229	16/9/05	1len'	
333	28R	/ / /		
375	296	6/11/05	1Cm	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
FAST update	6/9/01	/lui
Inventor Scarch	6/10/05	Olev